

beam homogenizer, laser irradiation apparatus, semiconductor device, and method of fabricating the semiconductor device

PTO-2040
12/99

WARNING:

The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368. Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.

Form PTO-453A
(Rev. 8/89)

FILED WITH: DISK (CRF) FICHE CD-ROM
(Attached in pocket on right inside flap)

(Attached in pocket on right inside flap)